



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Koichi Ohto, et al.

Examiner: Ori Nadav

Serial No: 10/767,786

Art Unit: 2811

Filed: January 29, 2004

Docket: 17408

For: SEMICONDUCTOR DEVICE,
AND PRODUCTION METHOD
FOR MANUFACTURING SUCH
SEMICONDUCTOR DEVICE

Dated: May 5, 2006

Confirmation No. 7289

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT UNDER 37 C.F.R. § 1.115

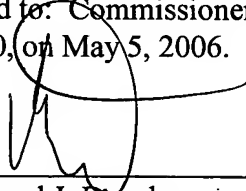
Sir:

In conjunction with the contemporaneously filed Request for Continued Examination under 37 C.F.R. §1.114, please enter the following amendments and consider the accompanying remarks.

CERTIFICATE OF MAILING UNDER 37 C.F.R. 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Mail Stop RCE, P.O., Box 1450, Alexandria, VA 22313-1450, on May 5, 2006.

Dated: May 5, 2006


Richard J. Danyko